

**PATENT** 5181-84400/P5958

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:				§	Group Art Unit	: 2123
	Smith	et al.			Examiner: Unk	nown
Serial No. 09/841,912				§ §	Atty. Dkt. No. 5	5181-84400
Filed: For:	SYSTEM AND METHOD FOR DETERMINING THE REQUIRED DECOUPLING CAPACITORS FOR A POWER DISTRIBUTION SYSTEM USING AN IMPROVED CAPACITOR MODEL			<i>\$</i>	U.S. Postal Service as First Class Commissioner for Patents, P.O. El 1450, on the date indicated below  B. Noë Registered R  Date Signature	RECEIVED
			INFORMATION DIS	<u>CLO</u>	SURE STATEMENT	NOV 2 8 2003
Commissioner for Patents Washington, D.C. 20231  Technology Center					Technology Center 2100	
Sir:						
	Applica	ant requ	ests consideration of 🛛	the re	ferences listed on the at	tached Form PTO-1449
and/or	the a	dditiona	l information identified be	low ir	paragraph 3. A copy of	each reference listed on
the For	m PTO-	1449 is 6	enclosed.			
1.	This In	formatio	on Disclosure Statement is s	tted:		
	a.		within 3 months of the file prosecution application un within 3 months of the dat an International application before the mailing date of before the mailing of a continued examination un	nder § te of e on; a first	1.53(d); entry of the national stage t Office Action on the men Office Action after the	as set forth in § 1.491 in
	b. after the events of above paragraph 1a and prior to the mailing date of a final Office Action or Notice of Allowance, and thus:  the certification of paragraph 2 below is provided, or a fee of \$180.00 is enclosed.					

	c.	after the mailing date of a final Office Action or a Notice of Allowance and prior to payment of the issue fee, and thus: the certification of paragraph 2 below is provided and a fee of \$180.00 is enclosed.					
2.	It is hereby certified:						
	$\boxtimes$	that each item of information contained in this Information Disclosure Statement cited in a communication from a foreign patent office in a counterpart foreign applic not more than three months prior to the filing of the Statement, or					
		that no item of information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the person signing the certification after making reasonable inquiry, was known to any individual designated in § 1.56 (c) more than three months prior to the filing of the Statement.					
3.		Consideration of the following additional information (including any co-pending or abandoned U.S. applications, prior uses and/or sales, etc.) is requested:					
4.	For each non-English language reference listed on the attached Form PTO-1449:						
		reference is made to an English language translation submitted herewith, and/or					
		reference is made to a foreign patent office search report (in the English language) submitted herewith, and/or					
		reference is made to an English language translation of a foreign patent office search report submitted herewith, and/or					
·		reference is made to the concise explanation contained in the specification of the present application at page(s), and/or					
		reference is made to the concise explanation set forth below:					
5.		Applicant also offers the following comments for the Examiner's consideration:					
6.	$\boxtimes$	Also enclosed is a copy of a foreign search report citing these references.					
7.		The listed documents were brought to the attention of the Applicant(s) after payment of the issue fee in the captioned case. The documents were cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. Applicant(s) request this Information Disclosure Statement and attached Form PTO-1449 be placed in the file of the captioned application.					
8.		Applicant(s) requests that the Information Disclosure Statement and attached Form PTO-1449 and references, which are being filed before the grant of the patent and pursuant to 37 C.F.R. § 1.97(i), be placed in the file of the captioned application.					

If any required fees are missing, the Commissioner is authorized to charge said fees to Meyertons, Hood, Kivlin, Kowert & Goetzel, P.C. Deposit Account No. 50-1505/5181-84400.

Respectfully submitted,

B. Noël Kivlin

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Date: 11-20-03

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	~	cant's Information	BPPLICAN	PPLICANT: Smith et al.			GROUP: 2123					
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(Use several sheets if necessary)  PATENT DOCUMENTS												
EXAM. REF. DOCUMENT NUMBER DATE NAME CLASS SUB FILING DATE												
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EXAM. INITIALS	REF. DES.	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATIO YES/NO					
	C1	99/66554	12/23/99	WO								
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	C2		<u></u>	er PCT/US02/12707 mailed		4, 2003						
	C3	"High Frequency Model for Power Electronics Capacitors", Siami, et al, <u>IEEE Transactions on Power</u> Electronics, March 2001, IEEE, US, Vol 16, No. 2, pages 157-166.										
	C4	"A Study of the High Frequency Performance of Thin Film Capacitors for Electronic Packaging", Chen, et al, IEEE Transactions on Advanced Packaging, May 2000, IEEE, US, Vol 23, No. 2, pages 293-302.										
	C5	"A High Frequency Model Based on the Physical Structure of the Ceramic Multilayer Capacitor", de Vreede, et al, <u>IEEE Transactions on Microwave Theory and Techniques</u> , July 1992, IEEE, US, Vol 40, No. 7, pages 1584-1587.										
	C6	"Distributed SPICE Circuit Model for Ceramic Capacitors", Smith, et al, 2001 Proceedings, 51st Electronic Components and Technology Conference 2001, Orlando, FL, May 29-June 1, 2001, pages 523-528										

## **EXAMINER:**

## DATE CONSIDERED:

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the patent owner.